

Notice of References Cited	Application/Control No. 10/654,619	Applicant(s)/Patent Under Reexamination LEWIN ET AL.	
	Examiner Van Kim T. Nguyen	Art Unit 2456	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,125,116	09-2000	Dighe et al.	370/395.1
*	B	US-5,999,565	12-1999	Locklear et al.	375/222
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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